

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re New Patent Application of)
Osamu NAKAMURA et al.)
Japanese Priority Application No. 2001-019367) Attn: Applications
Japanese Priority Date: January 29, 2001) Branch
For: SEMICONDUCTOR DEVICE AND)
MANUFACTURING METHOD OF)
THE SAME) Date: January 28, 2002



INFORMATION DISCLOSURE STATEMENT

Honorable Commissioner for Patents and Trademarks
Washington, D.C. 20231

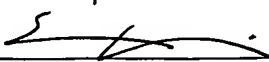
Sir:

In accordance with the provisions of 37 C.F.R. 1.56 and 37 C.F.R. 1.97-1.99, it is requested that the references listed on the attached Form PTO-1449 be made of record in the above-identified application.

At least some of the references listed on PTO Form-1449 are discussed in the specification of the present application.

Copies of these references are submitted herewith in accordance with 37 C.F.R. 1.98(a).

Respectfully submitted,


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PTO/SB/08A (08-00)

Approved for use through 10/31/2002. OMB 0651-0031

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| | | | | Application Number | |
| | | | | Filing Date | |
| | | | | First Named Inventor | |
| | | | | Group Art Unit | |
| | | | | Examiner Name | |
| | | | | Attorney Docket Number | |
| Sheet | 1 | of | 1 | 740756-2428 | |

| U.S. PATENT DOCUMENTS | | | | | | |
|--------------------------------|-----------------------|----------------------|--------------------------------------|---|---|---|
| Examiner Initials [*] | Cite No. ¹ | U.S. Patent Document | | Name of Patentee or Applicant of Cited Document | Date of Publication of Cited Document MM-DD-YYYY | Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear |
| | | Number | Kind Code ² (if known) | | | |
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| OTHER PRIOR ART – NON PATENT LITERATURE DOCUMENTS | | | |
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